

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 119051	APPLICATION NO. 10/796,018
INFORMATION DISCLOSURE STATEMENT <i>(Use several sheets if necessary)</i>		APPLICANT(S) Tsuyoshi YAMADA et al.			
<i>O I P JAN 26 2007 PATENT & TRADEMARK OFFICE</i>		FILING DATE March 10, 2004		GROUP 2828	
U.S. PATENT DOCUMENTS					
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
JM	1. 4,425,648	1/10/1984	HOLLY		
JM	2. 5,144,630	9/1/1992	LIN		
	3. 5,249,192	9/28/1993	KUZENGA et al.		
JM	4. 5,331,649	7/19/1994	DACQUAY et al.		
JM	5. 5,345,457	9/6/1994	ZENZIE et al.		
JM	6. 5,528,612	6/18/1996	SCHEPS et al.		
JM	7. US 2002/0061037 A1	5/23/2002	SCHMID et al.		
JM	8. US 6,636,537 B2	10/21/2003	TAKADA		
FOREIGN PATENT DOCUMENTS					
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
JM	9. JP A 10-65238 w/abstract & transl.	3/6/1998	JAPAN		
JM	10. JP A 2002-134816 w/abstract & transl.	5/10/2002	JAPAN		
JM	11. JP A 2001-257398 w/abstract & transl.	9/21/2001	JAPAN		
JM	12. JP A 2002-151774 w/abstract & transl.	5/24/2002	JAPAN		
JM	13. JP A 2003-204099 w/abstract & transl.	7/18/2003	JAPAN		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)					
JM	14.	Clarkson et al.; "Simple method for reducing the depolarization loss resulting from thermally induced birefringence in solid-state lasers"; Optics Letters, Vol. 24, No. 12; June 15, 1999; pp 820-822			
JM	15.	Extended Abstracts (The 63 rd Autumn Meeting, 2002); The Japan Society of Applied Physics; September 24-September, 27, 2002			
JM	16.	Extended Abstracts (The 50 th Spring Meeting, 2003); The Japan Society of Applied Physics and Related Societies; March 27-March 30, 2003			
JM	17.	Extended Abstracts (The 64 th Autumn Meeting, 2003); The Japan Society of Applied Physics; August 30-September 2, 2003			
JM	18.	Reports on the 313 th Topical Meeting of the Laser Society of Japan; September 17, 2003			
JM	19.	Program (24 th Annual Meeting of Japan Society for Laser Surgery and Medicine); November 14-November 15, 2003			
JM	20.	Digest of Technical Papers; (24 th Annual Meeting of the Laser Society of Japan); January 29-January 30, 2004			
EXAMINER		/James Menefee/		DATE CONSIDERED 02/20/2007	
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.					

Date: May 21, 2004